PATENT
Docket No.: 50544.00003 (NVLS 387)

INFORMATION DISCLOSURE CITATION IN AN APPLICATION	DOCKET NUMBER	APPLICATION NUMBER
	50544.00003 (NVLS 387)	09/888,017
	APPLICANT	
(Use several sheets if necessary)	Craig L. Stevens	
	FILING DATE	GROUP ART UNIT
	June 21, 2001	2812

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
₥ᵤ	A	4,917,556	04/17/90	L. R. Stark, et al.	414	217	
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
	N							

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

₥ᵤ	O	"Operator's Handbook," MB^2 Modular Sputtering System, <u>Varian Semiconductor Equipment</u>, TFS Technical Publications, October, 1994, Table of Contents, i – iv; Pages 1-2, 2-1, 2-6; 3-1, 3-2; 4-1, 4-4; 5-24.
	P	"Drawings & Schematics Manual" Backbone Vol. 1, MB^2 Modular Sputtering System, <u>Varian Semiconductor Equipment</u>, TFS Technical Publications, June 1996, Table of Contents, i – vii; Index by Drawing Title, viii – xiii; Index by Drawing Number, xiv – xix.
	Q	"Various Engineering Drawings for Varian Semiconductor Processing System," <u>Varian Associates</u>, Exact Dates Unknown, Pages 244 245, 247 - 272- 274-1.

EXAMINER	KARLA MOORE	DATE CONSIDERED	12/1/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not information and not considered. Include copy of this with next communication to applicant.

In re: *Craig L. Stevens*

21097

INFORMATION DISCLOSURE CITATION IN AN APPLICATION *(Use several sheets if necessary)*	DOCKET NUMBER 50544.00003 (NVLS 387)		APPLICATION NUMBER Unassigned	
	APPLICANT Craig L. Stevens			
	FILING DATE June 21, 2001		GROUP ART UNIT Unassigned	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	5,186,718	02/16/93	Avi Tepman, et. al.	29	25.01	04/15/91
	B	4,917,556	04/17/90	Lawrence R. Stark, et. al.	414	217	05/26/89
	C	5,135,608	08/04/92	Ken Okutani	156	643	07/10/90
	D	5,314,541	05/24/94	Masasi Saito, et. al.	118	725	05/28/92
	E	6,048,154	04/11/00	Joe Wytman	414	217	10/02/96
	F	4,705,951	11/10/87	Frederick P. Layman, et. al.	250	442.1	04/17/86
	G	4,228,358	10/14/80	Geoffrey Ryding	250	457	10/14/80
	H	4,042,128	08/16/77	Robert L. Shrader	214	17 B	11/26/75
	I	5,518,542	05/21/96	Hiroyuki Matsukawa, et. al.	118	52	11/04/94
	J	4,851,101	07/25/89	Martin A. Hutchinson	204	298	09/18/87
	K	4,795,299	01/03/89	Donald R. Boys, et. al.	414	217	04/15/87
	L	5,676,590	10/14/97	Naoki Hiraoka	451	287	12/29/95
	M	5,753,133	05/19/98	Jerry Wong, et. al.	216	67	07/11/94
	N	5,902,088	05/11/99	Kevin Fairbairn, et. al.	414	217	11/18/96
	O	5,961,722	10/05/99	Gayle Buhrer, et. al.	118	712	11/26/97
	P	6,007,675	12/28/99	Masato Toshima	156	345	12/01/97
	Q	5,186,594	02/16/93	Masato M. Toshima, et. al.	414	217	04/19/90
	R	5,512,320	04/30/96	Norman L. Turner, et. al.	427	255	04/13/94
	S	5,882,165	03/16/99	Dan Maydan, et. al.	414	217	09/10/97
	T	5,951,770	09/14/99	Ilya Perlov, et al.	118	719	06/04/97

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
	U							

In re: *Craig L. Stevens*

19027

		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
ꝀꞀ	V	John F. O'Hanlon, et al: "Reduction of water aerosol contamination during pumping of a vacuum chamber from atmospheric pressure" <u>American Vacuum Society</u>, J. Vac.Sci.Technol. A 9 (5); Sep/Oct 1991, Pages 2802-2807

EXAMINER KARLA MOORE	DATE CONSIDERED 12/01/02

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